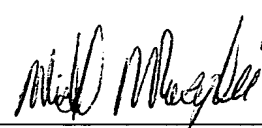




Serial No. 10/652,323

Atty. Docket 30320/15128  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.	: 10/652,323	)	I hereby certify that this paper and the
		)	documents referred to therein are being
Applicants	: Elqaq et al.	)	deposited with the United States Postal
Filed	: August 29, 2003	)	Service with sufficient postage, as first
		)	class mail, in an envelope addressed to:
Title: Method of Making an Optical		)	Commissioner for Patents, P.O. Box 1450,
Device in Silicon		)	Alexandria, VA 22313-1450
		)	
Art Unit	: Not yet assigned	)	Dated: November 25, 2003
Examiner	: Not yet assigned	)	
		)	
Atty Docket	: 30320/15128	)	
Customer No.	: 04743	)	_____ Michael Muczynski

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The publications listed on the enclosed Form PTO-1449 are submitted pursuant to 37 CFR §§ 1.56, 1.97, and 1.98. Copies of the publications are enclosed as necessary.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

By:

  
\_\_\_\_\_  
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Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 30320/15128	Serial No. 10/652,323
<b>INFORMATION DISCLOSURE STATEMENT</b>		Applicant Elqaq et al.	
		Filing Date August 29, 2003	Group

U.S. PATENT DOCUMENTS							
*Examiner Initials		Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate

FOREIGN PATENT DOCUMENTS								
*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
		"Amorphous Silicon Waveguides and Light Modulators for Integrated Photonics Realized by Low Temperature Plasma Enhanced Chemical Vapor Deposition," <i>Opt. Lett.</i> vol. 21, no. 24, p. 2002-2004 (1996).
		B. Jalali et al., "Advances in Silicon-on-Insulator Optoelectronics" <i>IEEE J. Sel. Top. Quantum Elec.</i> , vol. 4, no. 6, p. 938-947 (Nov./Dec. 1998).

Examiner	Date Considered
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	